

PATENT
Docket No. 150.00840102IN THE UNITED STATES PATENT AND TRADEMARK OFFICERECEIVED
CENTRAL FAX CENTER

APR 26 2004

OFFICIAL

Applicant(s): Yates et al.)
Serial No.: 10/770,797)
Confirmation No.: Unassigned)
Filed: 3 February 2004)
For: COMPOSITIONS AND METHODS FOR REMOVING ETCH RESIDUE

Group Art Unit: Unassigned
Examiner: Unassigned

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CERTIFICATE UNDER 37 C.F.R. §1.8: The undersigned hereby certifies that this Facsimile Cover Sheet and the paper(s), as described hereinabove, are being transmitted by facsimile in accordance with 37 CFR §1.6(d) to the Patent and Trademark Office addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 26th day of April, 2004, at 3:20pm (Central Time).

April 26, 2004
Date

Signature: [Signature]

Name: SALE E. OLSON

If you do not receive all pages, please contact us at (612)305-1220 (ph) or (612)305-1228 (fax).

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INFORMATION DISCLOSURE STATEMENTCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with C.F.R. §§ 1.97 *et. seq.*, the materials enclosed herewith are brought to the attention of the Examiner as possibly being of interest in connection with the above-identified patent application. Per M.P.E.P. § 609, the information cited in the present Information Disclosure Statement shall not be construed to be an admission that the information is, or is considered to be, material to patentability. Consideration of each of the documents listed on the attached 1449 form(s) is respectfully requested. As this patent application was filed after June 30, 2003, copies of the U.S. patents and U.S. patent application publications listed on the attached 1449 form(s) have not been submitted. Pursuant to the provisions of M.P.E.P. §609, Applicants further request that a copy of the 1449 form(s), marked as being considered and initialed by the Examiner, be returned with the next Official Communication.

This application is a divisional of U.S. Patent Application Serial No. 09/595,714, filed June 16, 2000. In accordance with 37 C.F.R. §1.98(d), copies of documents previously cited by or submitted to the U.S. Patent and Trademark Office in connection with Applicants' prior application(s) listed above, are not included herewith.

Information Disclosure Statement

Page 2 of 2

Applicant(s): Yates et al.

Serial No.: 10/770,797

Filed: February 3, 2004

For: COMPOSITIONS AND METHODS FOR REMOVING ETCH RESIDUE

It is believed that no fee is due, as this Information Disclosure Statement is filed prior to the receipt of any Action on the merits. However, in the event a fee is due, please charge any fee or credit any overpayment to Account No. 13-4895.

The Examiner is invited to contact Applicants' Representatives at the below-listed telephone number, if they can be of any assistance during prosecution of the present application.

CERTIFICATE UNDER 37 C.F.R. 1.8:


The undersigned hereby certifies that this paper is being transmitted by facsimile in accordance with 37 CFR §1.6(d) to the Patent and Trademark Office, addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 26th day of April, 2004, at 3:20pm (Central Time).


Name: SARA E. OLSON

April 26, 2004
Date

Respectfully submitted for
Yates et al.

By
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INFORMATION DISCLOSURE STATEMENT	Atty. Docket No.: 150.00840102	Serial No.: 10/770,797
	Applicant(s): Yates et al.	Confirmation No.: Unassigned
	Application Filing Date: February 3, 2004	Group: Unassigned
	Information Disclosure Statement mailed: April 26, 2004	

U.S. PATENT DOCUMENTS

Examiner Initial	Copy Enclosed	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
		3,968,565	07/13/76	Bertens et al.			
		5,545,289	08/13/96	Chen et al.			
		5,741,368	04/21/98	Sahbari			
		5,780,359	07/14/98	Brown et al.			
		5,811,022	09/22/98	Savas et al.			
		5,851,302	12/22/98	Solis			
		5,876,903	03/02/99	Ng et al.			
		5,891,803	04/06/99	Gardner			
		6,063,712	05/16/00	Gilton et al.			
		6,162,738	12/19/00	Chen et al.			
		6,703,319	03/09/04	Yates et al.			

FOREIGN PATENT DOCUMENTS

Examiner Initial	Copy Enclosed	Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
		0662705 A2	12/29/94	Europe				
		0773480 A1	11/13/96	Europe				
		411067703	03/9/99	Japan				
		WO 99/45443	09/10/99	PCT				

OTHER DOCUMENTS (Including Authors, Title, Date, Pertinent Papers, etc.)

Examiner Initial	Copy Enclosed	Document Description
		"Material Safety Data Sheet for PRX-407®", Silicon Valley Chemlabs, Inc., Sunnyvale, VA 94086, 1998:4 pgs.

EXAMINER	Date Considered
<small>*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>	

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	Information Disclosure Statement mailed: April <u>26</u> , 2004	

Examiner Initial	Copy Enclosed	Document Description
		"Material Safety Data Sheet", Shipley, <i>PRX-407 Advanced Plasma Etch Polymer Remover</i> , July 26, 2000:7 pgs.
		Product information for: PRX-407 [®] Advanced Plasma Etch Polymer Remover, Silicon Valley Chemlabs, Inc., Sunnyvale, CA 94086, 1998
		"Post-Etch SWP Removal," SVC Silicon Valley Chemlabs, Inc., Sunnyvale, CA 94086:5 pgs.
		"Product Selection Guide," SVC Silicon Valley Chemlabs, Inc., Sunnyvale, CA 94086:2 pgs
		Sotoaka et al., "Cleaning solvent for manufacturing semiconductor element and semiconductor element using the same," English Abstract of JP 411067703 A:1 pg.

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